



Docket No.: 065933-0056

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Yoshio OKAYAMA, et al.

RESPONSE UNDER 37 C.F.R. 1.116  
EXPEDITED PROCEDURE

Application No.: 10/724,111

Filed: December 01, 2003

Customer No.: 20277  
Confirmation No.: 9924

Group Art Unit: 2812

Examiner: Lynne A. Gurley

Title: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE

**AMENDMENT UNDER 37 C.F.R. § 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the Office Action dated March 13, 2006. Please amend the above-identified application as follows.